




Substitute for form 1449A/PTO				<b>Complete if Known</b>	
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (use as many sheets as necessary)				Application Number	not yet assigned
				Filing Date	herewith
				First Named Inventor	FORTIN et al.
				Group Art Unit	not yet assigned
				Examiner Name	not yet assigned
Sheet	1	of	1	Attorney Docket Number	139641

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
	A	J.-S. PARK and Y.B. GIANCHANDANI, "A Low Cost Batch-Sealed Capacitive Pressure Sensor," IEEE No. 0-7803-5194-0 (1999)	
	B	A. V. CHAVAN and K. D. WISE, "A Monolithic Fully-Integrated Vacuum-Sealed CMOS Pressure Sensor," IEEE No. 0-7803-5273-4 (2000)	
	C	WEN H. KO and QIANG WANG, "Touch Mode Capacitive Pressure Sensors For Industrial Applications," IEEE No. 0-7803-3744-1 (1997)	
	D	HYEONCHEOL KIM and KUKJIN CHUN, "Integrated MEMS for Pressure Transponder," 1997 International Conference on Solid-State Sensors and Actuators, IEEE No. 0-7803-3829-4 (1997)	
	E	W. P. EATON and J. H. SMITH, "Micromachined Pressure Sensors: Review and Recent Developments," Smart Mater. Struct. 6, p 530-539 (1997)	
	F	ABHIJEET V. CHAVAN and KENSALL D. WISE, "A Monolithic Fully-Integrated Vacuum-Sealed CMOS Pressure Sensor," IEEE Transactions on Electron Devices, Vol. 49, No. 1 (January 2002)	
	G	C. HIEROLD et al., "Implantable Low Power Integrated Pressure Sensor System for Minimal Invasive Telemetric Patient Monitoring," IEEE No. 0-7803-4412-X (1999)	

Examiner Signature		Date Considered	1-4-05
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup>Unique citation designation number. <sup>2</sup>Applicant is to place a check mark here if English language Translation is attached.

FORM PTO-1449  
(REV. 7-80)  
(Title Amended 3/83)

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE

ATTY. DOCKET NO.

139641

SERIAL NO.

10/799,053

## INFORMATION DISCLOSURE STATEMENT BY APPLICANT--

## LIST OF ITEMS

(Use several sheets if necessary)

Applicant

K. Subramanian et al.

Filing Date

03/12/04

Group

2855

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>dl</i>	AA 6 4 6 0 2 3 4	10/08/02	Y. Glanchandani			
	AB					
	AC					
	AD					
	AE					
	AF					
	AG					
	AH					
	AI					
	AJ					
	AK					

## FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	No
<i>dl</i>	AL 1 3 5 3 1 6 1	10/04/02	EPO				
<i>dl</i>	AM 4 2 2 3 6 1 6	07/17/92	Germany				
	AN						
	AO						
	AP						

## OTHER INFORMATION (Including Author, Title, Date, Pertinent pages. Etc.)

AR	EP Search Report 10-18-05
AS	
AT	

EXAMINER

*dl*

DATE CONSIDERED

1-5-06

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